Two-photon absorption study of GaN

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Two-photon absorption coefficients of GaN for below band gap ultraviolet wavelength and midgap infrared wavelength were measured by using femtosecond pulsewidth autocorrelation and Z-scan techniques. Large two-photon absorption coefficients were obtained. Taking advantage of the large two-photon absorption, we have demonstrated two-photon confocal imaging of a GaN thin film. Direct correlation was found between the yellow luminescence and suppression of bandedge luminescence. © 2000 American Institute of Physics. [S0003-6951(00)04404-1]

GaN and its related materials have attracted great interest for their applications in light emitters in the green to ultraviolet (UV) wavelength.1 Recently there has been a growing attention on the studies of the two-photon absorption (TPA) process in GaN, which will lead to optical power limitation and optical damages in nitride based optoelectronics. Taking advantage of the TPA process in GaN thin films and photodetectors, autocorrelation and cross-correlation of visible and infrared (IR) femtosecond pulses have been demonstrated by several research groups.2−5 TPA induced photoluminescence (PL) of GaN was also previously studied6 using tunable picosecond pulses. A large TPA coefficient \( \beta \) of 17.5 cm/G W at 600 nm wavelength was reported.2 A value of \( \sim 1.5 \) cm/G W was also obtained for \( \beta \) at photon energies above \( E_{\text{gap}} \) in the IR wavelength region.7

In this letter, we report our study of the TPA of GaN in below band gap UV wavelength region using TPA-type autocorrelation techniques. The study of TPA process for below band gap UV-blue wavelength is important due to the fact that most nitride based optoelectronics are operated in this wavelength regime instead of in red or IR wavelength. On the other hand, optical autocorrelation of ultrashort pulses using TPA provides a convenient, sensitive, and inexpensive alternative to standard techniques using nonlinear crystals.8−10 UV TPA autocorrelation is especially important due to the difficulty of finding a suitable second-harmonic generation crystal in this wavelength regime. In order to avoid possible systematic errors by the two-photon autocorrelation technique, we have also performed single-beam Z-scan measurements for below band gap UV wavelengths.

The GaN sample was grown by atmospheric-pressure metalorganic chemical-vapor deposition on a doubleside polished c-plane sapphire substrate. After annealing the substrate and deposition of a nucleation layer, unintentionally doped GaN layer of 5 \( \mu \)m thickness was grown. The crystal structure is wurzite. A room-temperature transmission spectrum indicated that the band gap of the sample was located \( \sim 365 \) nm. The TPA study was performed by demonstrating UV TPA autocorrelation using a standard transmission-type pump-probe technique. The laser output from a femtosecond mode-locked Ti:sapphire laser was frequency doubled in a 500-\( \mu \)m-thick beta-barium-borate crystal to reach UV wavelength. The frequency-doubled UV pulses were tunable between 350 and 400 nm with a repetition rate of 82 MHz. The UV pulses were split as pump and probe pulses by a beamsplitter. These two beams were then focused onto the same point on the GaN sample by using an objective. The pump beam was chopped and the detected probe signal was measured as a function of the temporal delay between the pump and the probe by a lock-in amplifier. Complimentary transient reflection measurements were also performed in order to remove the transient contributions due to surface reflection.

Figure 1(a) shows the measured transient response using UV femtosecond pulses centered at a wavelength of 390 nm (open circles). Around zero time delay, a large transmission decrease was observed. This was induced by the TPA process. The differential transmission change of probe beam decreased linearly with the pump excitation power, indicating a TPA process consisted of one pump photon and one probe photon. The shape of the TPA-induced differential transmission decrease will mimic the pulse autocorrelation function. However, after the TPA decrease, the measured transient response did not return to zero but was followed by a small step-like positive transmission increase within our measured time delay (\( \sim 1 \) ps). This transmission increase is attributed to the absorption saturation of the bandtail states. This bandtail state absorption might be the origin of the nonideal interferometric autocorrelation pulse shape (a 6:1 ratio instead of an 8:1 ratio) obtained from a GaN photodetector using 410 nm pulses.4 In order to remove the contribution from the bandtail state saturation, we have performed a convolution fit. The fitting considers two components: a Gaussian pulse shape (negative, representing the TPA induced pulse-

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width autocorrelation) and its convolution with a step function (positive, representing the absorption saturation contribution). The dotted line on top of the experimental data is a convolution fit. The dotted line and the dashed lines in Fig. 1(b) are the corresponding contributions from the negative Gaussian pulse shape and its positive convolution component with the step function. The open circles in Fig. 1(b) are the corrected TPA autocorrelation trace after removing the step function contribution from the experimental data. An excellent fit with a Gaussian pulse shape was obtained. An autocorrelation full width at half maximum (FWHM) of 430 fs was obtained for this specific trace. A FWHM pulsewidth of 300 fs can thus be derived. The focal spot diameter of the UV beam, at which the electric field amplitude of the Gaussian beam decreases to 1/e of its peak value, was measured to be 15.7 μm determined by transmission through a 10 μm pinhole. The pump pulse energy inside the sample was 200 pJ, corrected after the surface Fresnel reflection. Considering the Gaussian spatial and temporal intensity profiles, the pump pulse energy inside the sample was 236 pJ with a focal beam diameter of 16.3 μm.

Similar measurements were also performed at wavelengths between 400 and 377 nm. Values of β between 16±7 and 12±6 cm/G W were obtained. For wavelength shorter than 375 nm, the transient response was found to be dominated by absorption saturation of band tail states, which will result in greater fitting errors. In order to confirm these measured results, we have also performed Z-scan measurements on the GaN sample. TPA coefficients of 17±7 and 14±6 cm/G W can be derived from Z-scan traces at wavelengths of 387 and 391 nm, respectively. These measured TPA coefficients of GaN at UV wavelengths are much larger than the reported UV TPA coefficients of diamond (0.75 cm/G W at 310 nm, 2.3 cm/G W at 282 nm) and fused silica (0.045 cm/G W at 267 nm), which have both been proposed as candidate TPA materials for UV pulse autocorrelation. The measured and thus obtained large TPA coefficients of GaN indicate great potential of nitride-based semiconductors as nonlinear crystals for visible-UV photonic applications. Even though the applicable wavelength is limited by the band gap energy of GaN (365 nm), it can be extended further into UV wavelength by adding aluminum composition into GaN.

Experiments were also performed at above midgap IR wavelength. With a band gap energy around 365 nm, TPA-induced band-to-band transition in GaN will allow photons with wavelength up to 730 nm. At above midgap IR wavelength, no defect transition is expected and a symmetric autocorrelation function should thus be obtained. Figure 2 shows a measured transient transmission trace on a 2.5-μm-thick GaN thin film using 720 nm fs pulses. A symmetric TPA-induced response was obtained, corresponding to the pulse autocorrelation function. The dotted line in Fig. 2 shows a Gaussian fit with a FWHM of 200 fs. A pulsewidth of 140 fs can thus be derived. The pump pulse energy inside the sample was 236 pJ with a focal beam diameter of 16.3 μm. A maximum probe transmission decrease of 0.04% will thus correspond to a β of 3±1.5 cm/G W at 720 nm wavelength. At 690 nm wavelength, a β of 7±3 cm/G W was also obtained in a similar measurement procedure.

Figure 3 summarizes the measured results. Open circles represent the values obtained from TPA autocorrelation measurements, while open triangles represent the values from Z-scan measurements. Previously reported value at 600 nm is also displayed as a solid diamond for comparison. According to the study of Sheik-Bahae and his co-workers, TPA coefficient β of a direct band gap semiconductor at a photon energy $h\nu$ can be described by

$$\beta(h\nu) = K \sqrt{\frac{E_p}{n_o^2 E_g^3} F_2 \left(\frac{h\nu}{E_p}\right)},$$

with $F_2(x) = (2x-1)\frac{1}{x^2}$, $K = 1940$ while $\beta$ is in unit of cm/G W. $E_p$ is $\sim 21$ eV. $E_g$ is the band gap energy of GaN. $n_o$ is the refractive index of GaN. We plot 12 times of Eq. (1) as a dotted line in Fig. 3 for reference. Our measured results agree with the frequency dependence described by Eq. (1) but are larger by a constant, which is commonly observed in wide-band gap dielectrics. One of the possible reasons for the observed large constant is the negligence of
exciton effects in Eq. (1), while exciton effects are significant in GaN and are found to enhance TPA coefficient. Taking advantage of the large TPA coefficient of GaN at above midgap IR wavelength, two-photon confocal scanning microscopy on GaN can be easily demonstrated using femtosecond IR pulses. The use of IR wavelength leads to a deeper penetration depth in most materials, providing an opportunity to image thicker samples. For GaN studies, the use of IR excitation wavelength can also avoid most expensive opportunity to image thicker samples. For GaN studies, the use of IR excitation wavelength can also avoid most expensive UV optics. Figures 4 of IR excitation wavelength can also avoid most expensive opportunity to image thicker samples. For GaN studies, the use of IR excitation wavelength can also avoid most expensive UV optics. Figures 4(a) and 4(b) show the measured two-photon scanning PL images of a GaN Hall-measurement sample. Femtosecond pulses at wavelength of 720 nm were passed through XY galvano mirrors to perform two-dimensional scanning. The dithered laser beam was then directed into an inverted optical microscope (Olympus BX50). A 10 × objective was utilized to focus the laser beam onto the GaN layer. The valence band carriers were photoexcited into the conduction band by strong TPA processes and the subsequent PL was collected by the same microscope objective, separated from the input laser beam by a dichroic beamsplitter, and directed into a photomultiplier (PMT) tube. Due to the large wavelength difference between the excitation pulse and PL light, the PL photons can be easily separated from the pump laser beam. Combining with strong TPA in GaN, large signal-to-noise ratio can thus be easily achieved. Figure 4(a) shows an image taken with a 365 nm interference filter with 10 nm bandwidth in front of the PMT tube, corresponding to the GaN band gap wavelength at room temperature. Figure 4(b) shows an image taken with a 550–650 nm bandpass filter, corresponding to the wavelength of the defect yellow luminescence. Figure 4(c) shows an image taken with the transmitted 720 nm beam through the sample. The image was taken from the edge of the Hall-measurement sample with two oval defects. Figure 4(a) indicates excellent lateral uniformity in the measured sample except on the areas around oval defects. It is interesting to notice that the area emitting weak edge PL corresponds to the area emitting strong yellow PL. The yellow PL of GaN has been thought to compete with the edge PL and is studied intensively recently. Our demonstration indicates that two-photon confocal microscopy of GaN cannot only exhibits superior image quality but also reveals interesting details that are not readily available though other contrast mechanisms. In summary, we have studied TPA of GaN by demonstrating UV two-photon autocorrelation. Large TPA coefficient at below band gap UV wavelengths was observed, indicating GaN and it related materials as excellent candidates for UV nonlinear applications. Large β at above-midgap IR wavelengths was also observed. Taking advantages of this large β at above-midgap IR wavelengths, we have demonstrated two-photon confocal microscopy on a GaN Hall-measurement sample using IR femtosecond pulses. Direct correlation was found between yellow luminescence and suppression of bandedge PL.

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